Optimization of the window layer in large area silicon heterojunction solar cells

Yue Zhang, a Cao Yu, b Miao Yang, b Yongcai He, a Linrui Zhang, a Jinyan Zhang, b Xixiang Xu, b Yongzhe Zhang, **a Xuemei Song a and Hui Yan* a

Silicon heterojunction solar cells have shown great advantage due to their large open-circuit voltage which induces a high energy conversion efficiency. However, the short-circuit current density is limited by the high light absorption of an n-type amorphous silicon window layer in the short-wavelength range. Here an amorphous silicon oxide film was introduced to replace the window layer. The increasing oxygen content in amorphous silicon oxide layers leads to the enlarged optical band gap and the enhanced short-wavelength transmittance. As a result, the short-circuit current density increases obviously which comes from the high transmittance of amorphous silicon oxide films due to the wider band gap. Furthermore, the highly phosphorous-doped amorphous silicon layer was introduced to improve the contact between transparent conductive oxide layer and n-type amorphous silicon oxide layer. The carrier transport property is enhanced and thus the fill factor increases significantly. Finally, a silicon heterojunction solar cell with an area of 238.95 cm² was prepared, yielding a total-area efficiency up to 21.1%. Overall, the results indicate that amorphous silicon oxide films can be applied to silicon heterojunction solar cells as a window layer, which provides a new route to obtain higher energy conversion efficiency.

1. Introduction

Silicon heterojunction (SHJ) solar cells are fabricated through depositing thin hydrogenated amorphous silicon (a-Si:H) layers on crystalline silicon substrates. Due to the outstanding passivation effect of the intrinsic a-Si:H films,2,3 SHJ solar cells show high open-circuit voltage ($V_{OC}$) exceeding 750 mV which leads to high energy conversion efficiency.4 Upon the intrinsic a-Si:H films, doped (n-type or p-type) a-Si:H film is generally deposited to form a junction, which could separate the photo-generated carriers effectively.5 However, both the intrinsic and doped a-Si:H films contain lots of defects due to the presence of dangling bonds.6 In the respect of light absorption, it shows a high absorption in the short wavelength region (below 730 nm) due to the high absorption coefficient which comes from the quasi-direct band gap property of a-Si:H.7,8 Although the high absorption could lead to more photo-generated carriers, these carriers could not be pumped out due to the present of large density of defects.9 Z. C. Holman et al. pointed out that 70% carriers generated in intrinsic a-Si:H layers of heterojunctions recombined, and light absorbed in the doped a-Si:H layer had almost no contribution to short-circuit current density ($J_{SC}$).9 So decreasing the parasitic absorption of a-Si:H layers is a key point to improve $J_{SC}$. It has been demonstrated that decreasing the thickness of a-Si:H films is a useful method to improve $J_{SC}$ by decreasing absorption in short-wavelength region. However, the fill factor (FF) and $V_{OC}$ of SHJ solar cells decreased significantly because of the degrading of junction,10–12 the gain in $J_{SC}$ was offset by losses in FF and $V_{OC}$. Compared with a-Si:H films, hydrogenated amorphous silicon oxide (a-SiOx:H) films have much more advantages including wider band-gap and lower optical absorption.13 The absorption loss in short-wavelength region could be significantly reduced by adopting a-SiOx:H films and this strategy has worked in amorphous silicon solar cells.14,15 R. Biron et al. observed an enhancement of 0.6 mA cm⁻² in $J_{SC}$ in the short-wavelength region due to the enlargement of optical band gap of silicon oxide based emitter,16 and other studies have obtained similar results.17,18 Here phosphorus-doped a-SiOx:H film was introduced to replace the n-type a-Si:H window layer. For the passivation layer, intrinsic a-Si:H film was left to keep an excellent passivation effect.19 The optical properties of n-type a-SiOx:H films and the effect of n-type a-SiOx:H films on SHJ solar cell performance were investigated in details. By adjusting the CO2/SiH4 flow ratio, the optimized oxygen content in a-SiOx:H films was obtained. Furthermore, highly phosphorous-doped a-Si:H films was introduced to improve the contact between transparent conducting oxide (TCO) and n-type a-SiOx:H layers, which improved the FF obviously. Finally, SHJ solar cell with
large area of 238.95 cm² was obtained, yielding a high efficiency of 21.1%. All these results obtained could be much useful to the industrial production of SHJ solar cell.

2. Experimental

The a-Si/c-Si heterojunction solar cells were fabricated on commercial solar grade Czochralski silicon wafers (n type, 2–5 Ω cm, 200 μm thick, (100) oriented, 238.95 cm² wafer size). Surface texture was formed wet-chemically by alkaline process (aqueous solution of potassium hydroxide (1.5% wt)), then cleaned by RCA process before transferred to deposition chamber. Very high frequency plasma enhanced chemical vapor deposition (VH-PECVD, 40 MHz) reactor was used to prepare a-SiOₓ:H and a-Si:H films, the power density is 15 mW cm⁻² and the deposition pressure is 30 Pa. The TCO layers (indium tin oxide, 10% wt SnO₂-doped In₂O₃ ceramic target) and the silver back electrode were prepared by magnetron sputtering. Cells were finished with forming front electrodes by screen printing silver paste. The structure of the a-Si/c-Si heterojunction solar cells is shown in Fig. 1.

The current density–voltage (J–V) characteristics were obtained under standard test condition (STC, 25 °C, AM1.5G, 100 mW cm⁻²). External quantum efficiency (EQE) was used to evaluate the spectral response. Transmittance and reflectance were measured by PerkinElmer Lambda 950 spectrophotometer. Besides, a-SiOₓ:H and a-Si:H films were also investigated by Semilab PT-5 spectroscopic ellipsometry at room temperature using the Tauc-Lorentz method combined with the Bruggeman effective medium approximation (BEMA) model. Fourier transform infrared (FTIR) spectroscopy was used to verify the presence of oxygen for an approximately 100 nm thick layer. The one-sun (AM 1.5) photo-conductivity of different window n⁺ layers was measured by coplanar electrodes method using Keithley 2410, and the voltage applied between the two electrodes is 5 V. The length of the electrode is 16 mm and the spacing is 0.3 mm.

3. Results and discussion

3.1. Optical properties of n type a-SiOₓ:H

Fig. 2(a) presents the optical transmittance (T) and reflectance (R) spectra of n-type a-SiOₓ:H films with the same thickness of 8 nm deposited at various CO₂/SiH₄ flow ratios. It clearly shows that the transmittance of a-SiOₓ:H films increases with the increasing of CO₂/SiH₄ flow ratio in the wavelength from 300 to 1200 nm, especially in the region from 300 to 700 nm. The calculated absorbance (1 – T – R) result is shown in Fig. 2(b), where an obvious drop in the short-wavelength region is present with adjusting the CO₂/SiH₄ flow ratio. Fig. 3 represents the refractive indices (n) and extinction coefficients (k) of n-type a-SiOₓ:H films for an increasing CO₂/SiH₄ input flow ratio, derived from fitting spectroscopic ellipsometry data. It clearly shows that the refractive index decreases with the increase of CO₂/SiH₄ input flow ratio. This is the reason of the observed decrease of reflectance. It could be found that the extinction coefficient gradually decreases with the increase of CO₂/SiH₄ input flow ratio in the wavelength region from 300 nm to about 700 nm. As shown, extinction coefficient and absorption coefficient are positively correlated. Therefore, in the wavelength region from 300 nm to about 700 nm, the absorbance of a-SiOₓ:H films gradually decreases with the increase of CO₂/SiH₄ input flow ratio. In the wavelength region from 700 nm to 1200 nm, extinction coefficients are zero, indicating that a-SiOₓ:H films have no absorbance in this wavelength region. As a result of the differences in reflectance and absorbance, the transmittance of a-SiOₓ:H films increases with the increasing of CO₂/SiH₄ flow ratio in the wavelength from 300 to 1200 nm. Particularly in the wavelength region from 300 to 700 nm, due to the significant decrease of film absorbance, the increase of transmittance is more significant.
940 cm\(^{-1}\) and 1200 cm\(^{-1}\) represents the Si–O–Si stretching absorption band.\(^{20-22}\) It can be seen that the Si–O–Si stretching absorption gradually increases with the increase of CO\(_2\)/SiH\(_4\) flow ratio. The oxygen concentration (C\(_O\), units of at\%) in the a-SiO\(_x\):H films is estimated from the Si–O–Si stretching absorption band following G. Lucovsky et al.\(^{29}\) As is displayed in Fig. 4(b), the oxygen content gradually increases with the increase of CO\(_2\)/SiH\(_4\) flow ratio. Because of higher bond energy of Si–O bonds,\(^{24,25}\) the optical band gap (E\(_{\text{opt}}\)) increases from 1.71 eV to 2.08 eV, which is shown in Fig. 5. The relationship between E\(_{\text{opt}}\) and absorption coefficient of a-SiO\(_x\):H layers is displayed in eqn (1),\(^{24,25}\) where \(B\) is a constant, \(\hbar \omega\) is the energy of photon. According to eqn (1), absorption coefficient of a-SiO\(_x\):H layers decreases with the widening of E\(_{\text{opt}}\). So, the incorporation of oxygen in these films is the origination of the decreasing absorption in short wavelength region,\(^{19,23}\) this verifies the result of \(k\) presented in Fig. 3.

\[
\alpha(\omega)\hbar \omega = B(\hbar \omega - E_g)^2
\]  

(1)

3.2. Application of n-type a-SiO\(_x\):H in SHJ solar cells

Fig. 6 shows the illuminated \(J–V\) results of solar cells featuring n-type a-SiO\(_x\):H window layers of various CO\(_2\)/SiH\(_4\) flow ratios. As expected, \(J_{\text{SC}}\) shows a trend of increase. As is shown in Fig. 7, the enhancement of \(J_{\text{SC}}\) mainly originates from the improvement of spectral response in the short-wavelength region. This indicates that the high transmittance of a-SiO\(_x\):H layers in short-wavelength region indeed contributes to the \(J_{\text{SC}}\).

As for \(V_{\text{OC}}\), a slight drop can be seen with the increase of CO\(_2\)/SiH\(_4\) flow ratio. In this experiment, as the p side of the cell does not change, and n layers appear to have little detrimental effect on a-Si/c-Si chemical passivation quality.\(^{26}\) That means it is due to a loss in field effect passivation that the \(V_{\text{OC}}\) goes down. It has been confirmed that fourfold coordinated phosphorus atoms become more unlikely with increasing oxygen content in a-SiO\(_x\):H films,\(^{27}\) and the fourfold coordination of phosphorus atoms is crucial for an effective doping.\(^{28}\) This indicates that the doping efficiency of phosphorous in a-SiO\(_x\):H film decreases with rising oxygen content, and Fermi level moves towards the direction of middle of band gap.\(^{28}\) As a result, the built-in voltage (\(V_{\text{bi}}\)) of the n’/n junction in thermal equilibrium gradually decreases. This will result in the degradation in field effect passivation, and the recombination of the photo-generated carriers increases. Finally, the density of electrons (n) and holes (p) reduces. \(E_{\text{pn}}\) will move downwards with the decrease of electron density and \(E_{\text{pp}}\) will move upwards with the decrease of hole density gradually. Therefore, the \(V_{\text{OC}}\) which equal to quasi-Fermi splitting of electrons and holes continually reduces with the increase of CO\(_2\)/SiH\(_4\) flow ratio.

With the increase of CO\(_2\)/SiH\(_4\) flow ratio, energy conversion efficiency (\(E_{\text{in}}\)) gradually decreases. It can be easily found that the sharp decrease of FF is the main factor limiting the conversion efficiency of SHJ solar cell with n type a-SiO\(_x\):H film. In the next section, further analysis and corresponding optimization will be presented.

---

**Fig. 4** FTIR spectra of a-SiO\(_x\):H layers for various CO\(_2\)/SiH\(_4\) input flow ratios (a). Oxygen contents calculated from FTIR results (b).

**Fig. 5** Optical band gap as a function of CO\(_2\)/SiH\(_4\) flow ratio.

**Fig. 6** Illuminated \(J–V\) results of SHJ solar cells for various CO\(_2\)/SiH\(_4\) input flow ratios.

**Fig. 7** EQE spectra of SHJ solar cells for various CO\(_2\)/SiH\(_4\) input flow ratios.
3.3. Improvement of cell performance by highly phosphorous-doped a-Si:H buffer layer

Generally, FF is affected by series resistance and parallel resistance. The replacement of a-Si:H with a-SiO$_2$:H layer brings three changes including photo-conductivity (σ$_{ph}$) of n$^+$ layer, i/n$^+$ interface band structure and TCO/n$^+$ contact characteristic, which may weaken the transport of photo-generated carriers and result in the increase of series resistance. Fig. 8 shows the σ$_{ph}$ of phosphorous-doped a-SiO$_2$:H layers as a function of CO$_2$/SiH$_4$ flow ratio. A gradual decrease in σ$_{ph}$ can be observed. The σ$_{ph}$ is related to the recombination of optically excited carriers, the observed decrease of σ$_{ph}$ is mainly due to the increase of the density of recombination centers.\cite{29-31} Moreover, the decreased doping efficiency of phosphorous and increasingly intrinsic character with the increase of oxygen content will affect the σ$_{ph}$.\cite{28,32,33} In order to obtain high transmittance, the cost of low σ$_{ph}$ cannot be avoided for a-SiO$_2$:H films. Additionally, the increase in $E_{ph}$ with increasing CO$_2$/SiH$_4$ flow ratio results in the enlargement in the band offset at the i/n interface.\cite{24} In this experiment, electrons are collected at the front, an increasing conduction band offset ($\Delta E_c$) shown in Fig. 9(a) at the interface between intrinsic a-Si:H layer and n-type a-SiO$_2$:H layer may be detrimental, resulting in less efficient transport of carriers. Meanwhile, the increase of oxygen in n-type a-SiO$_2$:H layer results in the decrease of carrier density and drop of Fermi level. Therefore, the contact between n$^+$ layer and TCO layer is also affected. This may also limit the transport of photo-generated carriers.

In order to investigate the influence of $\Delta E_c$ on the transport characteristic of photo-generated electrons, AFORS-HET was used to simulate the device performance. The contacts between TCO and a-Si:H (p$^+$ and n$^+$) were assumed as flat band to neglect the potential contact influence, and the Fermi level and the valence band bottom of the a-SiO$_2$:H layer were assumed to be fixed to neglect the potential valence band offset influence. Detailed information of the substrate and amorphous silicon layers could be found in Table 1, the simulation result is shown in Fig. 9(b). From Fig. 9(b), the FF does not show a sharp decrease until $\Delta E_c$ is larger than 0.4 eV, the value is similar to that other groups have concluded.\cite{35,36} In this experiment, the band gap of intrinsic a-Si:H is approximately 1.71 eV, and the band gap of n-type a-SiO$_2$:H layers changes from 1.71 eV to 2.08 eV. This means that the $\Delta E_c$ at the i/n$^+$ interface would not exceed 0.185 eV (half of the band gap difference), since $\Delta E_c$ is usually smaller than valance band offset ($\Delta E_v$)\cite{37-41}. That is to say, the i/n$^+$ interface band offset will not lead to the significant decrease of FF. So, the contact between phosphorous-doped a-SiO$_2$:H layer and TCO layer may be more responsible for the decrease of FF.

In a next step, solar cells with a highly phosphorous-doped a-Si:H buffer layer (2 nm) between the TCO layer and n-type a-SiO$_2$:H layer were prepared. The PH$_3$/SiH$_4$ flow ratio was 3% for the a-Si:H buffer layers, while 1.5% for the n-type a-SiO$_2$:H layers. Fig. 10 shows the illuminated I–V parameters of solar cells with highly doped a-Si:H buffer layers. The basic trends of $V_{OC}$, $J_{SC}$ and FF do not change, but Fig. 11 clearly shows that the decrease amplitude of FF significantly reduces due to the

![Fig. 8](image8.png) The photoconductivity of phosphorous-doped a-SiO$_2$:H layers as a function of CO$_2$/SiH$_4$ flow ratio.

![Fig. 9](image9.png) Energy band diagram at the i/n interface (a), simulated FF as a function of conduction band offset (b).

### Table 1 The set of values for the simulation of the SHJ solar cells

<table>
<thead>
<tr>
<th>Parameters</th>
<th>a-SiO$_2$ (n)</th>
<th>a-SiH (p)</th>
<th>i-layer</th>
<th>c-Si</th>
</tr>
</thead>
<tbody>
<tr>
<td>Dielectric constant</td>
<td>11.9</td>
<td>11.9</td>
<td>11.9</td>
<td>11.9</td>
</tr>
<tr>
<td>Thickness (nm)</td>
<td>8</td>
<td>15</td>
<td>7</td>
<td>2 × 10^6</td>
</tr>
<tr>
<td>Electron affinity (eV)</td>
<td>3.4–3.9</td>
<td>3.9</td>
<td>3.9</td>
<td>4.05</td>
</tr>
<tr>
<td>Band gap (eV)</td>
<td>1.71–2.21</td>
<td>1.71</td>
<td>1.71</td>
<td>1.12</td>
</tr>
<tr>
<td>Effective conduction band density (cm$^{-3}$)</td>
<td>$1 \times 10^{20}$</td>
<td>$1 \times 10^{20}$</td>
<td>$1 \times 10^{20}$</td>
<td>$1 \times 10^{20}$</td>
</tr>
<tr>
<td>Effective valence band density (cm$^{-3}$)</td>
<td>$1 \times 10^{20}$</td>
<td>$1 \times 10^{20}$</td>
<td>$1 \times 10^{20}$</td>
<td>$2.85 \times 10^{19}$</td>
</tr>
<tr>
<td>Doping concentration of acceptors (cm$^{-3}$)</td>
<td>0</td>
<td>8.30 × 10$^{19}$</td>
<td>0</td>
<td>0</td>
</tr>
<tr>
<td>Doping concentration of donors (cm$^{-3}$)</td>
<td>$6.90 \times 10^{19}$</td>
<td>$1 \times 10^7$</td>
<td>$1 \times 10^7$</td>
<td>$1.5 \times 10^{16}$</td>
</tr>
<tr>
<td>Thermal velocity of electrons (cm s$^{-1}$)</td>
<td>$1 \times 10^7$</td>
<td>$1 \times 10^7$</td>
<td>$1 \times 10^7$</td>
<td>$1 \times 10^7$</td>
</tr>
<tr>
<td>Layer density (g cm$^{-2}$)</td>
<td>2.328</td>
<td>2.328</td>
<td>2.328</td>
<td>2.328</td>
</tr>
</tbody>
</table>

This journal is © The Royal Society of Chemistry 2017 RSC Adv., 2017, 7, 9258–9263 | 9261
With the increase of CO$_2$/SiH$_4$ flow ratio, the standard cell (a-Si:H n+ layer) would show a decrease in FF when increasing the temperature, whereas the Fermi level. Contact characteristic due to higher carrier density and higher Fermi level.

Finally, a total-area conversion efficiency of 21.1% was achieved on 238.85 cm$^2$ SHJ solar cell when the CO$_2$/SiH$_4$ flow ratio is 0.25. Compared with the standard cell, it exhibits a relative improvement of 2% in conversion efficiency at room temperature. Generally, the standard cell (a-Si:H n$^+$ layer) would show a decrease in FF when increasing the temperature, whereas the cell with an oxide layer recovers gradually. This means the a-SiO$_x$:H cell has a low temperature coefficient, which might show a big advantage in the real power generation process.

4. Conclusions

In summary, n-type a-SiO$_x$:H layers were prepared and applied to SHJ solar cells as window n$^+$ layers. The $V_{OC}$ decreases slightly with the increase of CO$_2$/SiH$_4$ flow ratio, this may be caused by the dropping of Fermi level which is originated from gradually decreased phosphorous doping efficiency. The application of such layers decreases the n$^+$ layers’ absorption in short wavelength region, resulting in improvement in $J_{SC}$. Moreover, through the insertion of a-Si:H buffer layer, the contact between TCO layer and a-SiO$_x$:H layer is greatly improved. The best SHJ solar cell with a-SiO$_x$:H layer reached an efficiency of 21.1% ($V_{OC}$: 729 mV, $J_{SC}$: 37.6 mA cm$^{-2}$, FF: 77.0%, cell area: 238.95 cm$^2$). The application of wide band-gap a-SiO$_x$:H layers on SHJ solar cells shows potential in improving conversion efficiency, the optimal parameters of a-SiO$_x$:H layers need further research for a higher conversion efficiency in the future.

Acknowledgements

This work was supported by the National Natural Science Foundation of China (51302081, 61575010, 61575009, 11274028, 11274014), Beijing Nova Program (Z141109001814053) and the Science and Technology Commission of Beijing Municipality (Z151100003315018, Z151100003515004). Authors appreciate Mr Mingfang Dai, Dr Yuanmin Li, Dr Hui Zhao, Ms. Lan Chen at Hanergy Thin Film Solar Group, R&D Center, for great support and helpful discussions. Authors also acknowledge all the colleagues in Thin Film Lab of Beijing University of Technology.

Notes and references
